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SERIAL NUMBER 10/505,180	FILING DATE 08/31/2004 RULE	CLASS 438	GROUP ART UNIT 2818	ATTORNEY DOCKET NO. 257479US2PCT
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APPLICANTS

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** CONTINUING DATA *****
 This application is a 371 of PCT/JP03/00859 01/29/2003 *yes*

** FOREIGN APPLICATIONS ***** *N/A*

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature _____ Initials _____	STATE OR COUNTRY JAPAN	SHEETS DRAWING 38	TOTAL CLAIMS 1	INDEPENDENT CLAIMS 1
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TITLE
 Method for fabricating semiconductor device and acceleration sensor

FILING FEE RECEIVED 1178	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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